



Docket No.: 740819-430

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11/5/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Shinji NAKAMURA et al.)
Serial No. 09/680,054)
Filed: October 5, 2000)
For: SEMICONDUCTOR DEVICE, SEMICONDUCTOR)
SUBSTRATE, AND MANUFACTURE METHOD)

REQUEST FOR ACKNOWLEDGMENT FOR
CONSIDERATION OF DISCLOSED INFORMATION

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

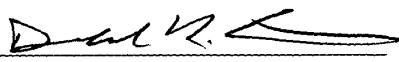
Sir:

An Information Disclosure Statement with Form PTO-1449 was filed in the above-captioned patent application on March 26, 2001. Applicants have not yet received back from the Examiner a copy of the Form PTO-1449 initialized to acknowledge the fact that the Examiner has considered the cited disclosed information.

The Examiner is requested to initial and return to the undersigned a copy of the subject Form PTO-1449.

Should there be any questions concerning this communication, please telephone the undersigned at the number set forth below.

Respectfully submitted,


Donald R. Studebaker
Reg. No. 32,815

Nixon Peabody LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 770-9300

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on 10-16-02

